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Broadband Infrared Standoff Spectroscopy with Interferometric Multilaser Pump-Probe Excitation-Detection

Disclosure Number

201503603

Technology Summary

The invention relates to standoff detection of compounds and more specifically to machines and methods for detecting analytes on target surfaces by providing the spectral signature of hazardous compounds such as biological and chemical contaminants on surfaces of vehicles, buildings, in industrial settings for quality control etc.

Inventor

PASSIAN, ALI Computational Sciences & Engineering Div

Licensing Contact

SIMS, DAVID L
UT-Battelle, LLC
Oak Ridge National Laboratory
Rm 124C, Bldg 4500N6196
1 Bethel Valley Road
Oak Ridge, TN 37831

Office Phone: (865) 241-3808 E-Mail: <u>SIMSDL@ORNL.GOV</u>